

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	3	((thick with (metal or conductive or conductor or conducting)) and NMOS and PMOS and (thin with (metal or conductive or conductor or conducting)) and (doped or doping) and silicon).clm.	US-PGPUB; USPAT	OR	ON	2005/08/10 15:41
L2	3780	438/244,253,386,398,630,649.ccls. and @ad<"20030312"	US-PGPUB; USPAT	OR	ON	2005/08/10 15:48
L3	751	2 and (CMOS or PMOS or NMOS)	US-PGPUB; USPAT	OR	ON	2005/08/10 15:49
L4	3	((thick with (metal or conductive or conductor or conducting)) and NMOS and PMOS and (thin with (metal or conductive or conductor or conducting)) and (doped or doping) and silicon)	USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/10 15:41
L5	4797	438/239,240,299,301,393,396.ccls. and @ad<"20030312"	US-PGPUB; USPAT	OR	ON	2005/08/10 15:49
L6	1210	5 and (CMOS or PMOS or NMOS)	US-PGPUB; USPAT	OR	ON	2005/08/10 15:49
L7	914	6 not 3	US-PGPUB; USPAT	OR	ON	2005/08/10 15:49